



APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER CRYSTALLIZATION PROCESS		
Application Type : regular, utility Attorney Docket Number : ADTP0068USA			
Correspondence address: Customer Number: 027765 			
Priority Data: Doc.No: 092112079; Country -TW ; Date: 2003-05-02 us-priority-claimed			
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